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APPLICATION NO.	F	ILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO
10/728,259		12/04/2003	David S. Keppel	2878 7800	
50855	7590	12/07/2006		EXAM	INER
		SURGICAL,	PEFFLEY, MICHAEL F		
A DIVISION OF TYCO HEALTHCARE GROUP LP 195 MCDERMOTT ROAD NORTH HAVEN, CT 06473				ART UNIT	PAPER NUMBER
				3739	

DATE MAILED: 12/07/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)						
Office Assistant Occurrence	10/728,259	KEPPEL, DAVID S.						
Office Action Summary	Examiner	Art Unit						
	Michael Peffley	3739						
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence address						
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tim rill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	I. nely filed the mailing date of this communication. D (35 U.S.C. § 133).						
Status								
1)⊠ Responsive to communication(s) filed on <u>03 No</u>	ovember 2006							
<u> </u>	action is non-final.							
· <u> </u>	☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is							
closed in accordance with the practice under E								
Disposition of Claims								
·								
	Claim(s) <u>1-21</u> is/are pending in the application. 4a) Of the above claim(s) is/are withdrawn from consideration.							
5) Claim(s) is/are allowed.	William Consideration.							
6) Claim(s) 1-21 is/are rejected.								
7) Claim(s) is/are rejected.	<u>.</u>							
•	Claim(s) is/are objected to. Claim(s) are subject to restriction and/or election requirement.							
are subject to restriction and/or	election requirement.							
Application Papers								
9) ☐ The specification is objected to by the Examine	r.							
10) ☐ The drawing(s) filed on is/are: a) ☐ acce	epted or b) objected to by the E	Examiner.						
Applicant may not request that any objection to the	drawing(s) be held in abeyance. See	e 37 CFR 1.85(a).						
Replacement drawing sheet(s) including the correct	ion is required if the drawing(s) is obj	ected to. See 37 CFR 1.121(d).						
11)☐ The oath or declaration is objected to by the Ex	aminer. Note the attached Office	Action or form PTO-152.						
Priority under 35 U.S.C. § 119								
12) ☐ Acknowledgment is made of a claim for foreign a) ☐ All b) ☐ Some * c) ☐ None of:	priority under 35 U.S.C. § 119(a)	-(d) or (f).						
	a have been received							
1. Certified copies of the priority documents		on No						
2. Certified copies of the priority documents	• •							
3. Copies of the certified copies of the prior	•	ed in this National Stage						
application from the International Bureau	, , , ,							
* See the attached detailed Office action for a list	or the certified copies flot receive	u.						
Attachment(s)								
1) Notice of References Cited (PTO-892)	4) Interview Summary							
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08)	Paper No(s)/Mail Da 5) Notice of Informal P							
Paper No(s)/Mail Date <u>10/6/06</u> .	6) Other:							
2.2								

Continued Examination Under 37 CFR 1.114

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on November 3, 2006 has been entered.

Claim Rejections - 35 USC § 103

Claims 1-3, 5-12 and 14-21 are rejected under 35 U.S.C. 103(a) as being unpatentable over Gines (6,033,399) in view of the teaching of Belt et al (4,191,188).

Gines discloses an electrosurgical generator that changes the output power of the generator based on sensed impedance (last line of the Abstract). In particular, impedance is measured using the output voltage and the output current of the waveform (see col. 9, lines 60-65) by a processing unit (12) which sends a signal to the waveform generator (12) to control the waveform being sent to tissue. It is noted that Gines disclose changing output power by changing the output voltage, and changing output voltage would inherently change the crest factor of the waveform. Hence, Gines is changing the output crest factor and output power based on the control signal from the impedance measurement processor. Gines specifically go on to state that the output power may be changed by changing the duty cycle or the crest factor of the output signal (col. 6, lines 40-50). The microprocessor (12) is deemed to be a data structure that includes data for setting the output power (or ceasing output power) based on

measured impedance. The controller takes data samples in real time to determine tissue impedance and immediately send a control signal to change the output of the generator.

Gines teach that the output power may be controlled by altering either the duty cycle or the crest factor, but fails to specifically disclose altering the duty cycle to adjust the crest factor. Gines also fail to disclose the specific formulas for determining the output crest factor based on duty cycle.

Belt et al disclose a system that alters the crest factor and output power by changing the duty cycle. The examiner maintains that any reasonable formula for arriving at the crest factor using an algorithm involving the duty cycle would be within the purview of the skilled artisan. It is noted that applicant's specification fails to provide any particular criticality or unexpected result associated with the formula set forth in claims 5 and 14. Belt et al also disclose a means to manually adjust the crest factor of the system (see col. 5, lines 29-36).

To have provided the Gines system with a control means to alter the duty cycle of the feedback system to control the output crest factor and output power would have been an obvious consideration for one of ordinary skill in the art since Belt et al teach that it is known to control output crest factor and power by varying the duty cycle. To have further provided any reasonable formula for arriving at the crest factor based on the duty cycle of the generator would have been an obvious consideration for one of ordinary skill in the art in view of the teaching of Belt et al. To have further provide a

manual control to set the crest factor would have been an obvious modification in view of the teaching of Belt et al.

Claim Rejections - 35 USC § 103

Claims 4 and 13 are rejected under 35 U.S.C. 103(a) as being unpatentable over Gines ('399) and Belt et al ('188) in view of the teaching of Carder (4,961,047).

The Gines system has been previously addressed. Gines specifically teaches of altering the output power of a generator based on sensed impedance, but fails to specifically teach using a look-up table as the means to correspond a measured impedance value with a generator output power. Gines also fail to disclose the specific formulas for determining the output crest factor based on duty cycle, although Gines does teach that the crest factor may be controlled by changing the duty cycle.

Carder discloses an electrosurgical generator that measures impedance and controls the output power of the generator in response to these measurements. In particular, Carder teach that it is known to use a look-up table associated with a processor to determine measure impedance based on sensed current and voltage, and to further use a look up table to determine a corresponding power output based on the impedance (see Abstract). To have employed a look-up table in the Gines microprocessor for assigning output values to measured impedances would have been an obvious consideration for one of ordinary skill in the art since Carder teaches that it is generally known to determine power outputs using look-up tables.

Response to Arguments

Applicant's arguments with respect to claims 1-21 have been considered but are moot in view of the new ground(s) of rejection.

Applicant has argued on pages 8 and 9 of the response that Gines teaches that the crest factor or the duty cycle may be changed to adjust output power, but fails to teach altering the duty cycle to adjust the crest factor as now set forth in the claims. The examiner maintains that the above cited Belt et al reference fairly teaches that it is known in the electrosurgical generator art to adjust duty cycle as a means to control the output crest factor and power of a system. As such, the examiner maintains that use of a control mechanism in the Gines system would be an obvious means to control the output of the system.

Applicant has also argued on page 11 of the response that there is no suggestion for combining the Belt teaching with the Gines reference since Belt fails to disclose an impedance feedback mechanism. The examiner disagrees. Gines clearly teach the impedance feedback system as well as the means to control power output by changing duty cycle or crest factor. Gines simply fails to explicitly acknowledge the adjustment of the crest factor by changing the duty cycle. The fact that Gines disclose adjusting the duty cycle would suggest that the crest factor is inherently also affected. However, the Belt et al reference is now cited to show that it is known in the art to adjust crest factor, and output power, by adjusting the duty cycle. Gines already provide the teaching of adjusting the output in response to the impedance measurements, and Belt et al is cited merely to show that it is known in the art to control output crest factor and power

through adjustment of the duty cycle. One of ordinary skill in the art would obviously know how to employ the use of such a duty cycle adjustment in the Gines system (which does control duty cycle) to control the output crest factor and power.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Michael Peffley whose telephone number is (571) 272-4770. The examiner can normally be reached on Mon-Fri from 6am-3pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Linda Dvorak can be reached on (571) 272-4764. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Primary Examine
Art Unit 3739

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December 4, 2006